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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Y. Long He et al.

Art Unit : 1763

Serial No. : 10/718,832

Examiner : Jeffrie Robert Lund

Filed : November 21, 2003

Title : PLASMA ETCHING UNIFORMITY CONTROL

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

REPLY OF INTEL CORPORATION TO ACTION OF JULY 1, 2004

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

October 15, 2004  
Date of Deposit

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